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(54) DISPLAY DEVICE AND MANUFACTURING METHOD THEREOF

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(57)ABSTRACT

According to one embodiment, a manufacturing method of a display device includes forming a lower electrode, forming a first insulating layer by depositing a first inorganic insulating material, stopping deposition of the first inorganic insulating material, forming a second insulating layer by depositing a second inorganic insulating material, forming a partition including a lower portion and an upper portion, forming an aperture which overlaps the lower electrode by patterning the second insulating layer and the first insulating layer in series, forming an organic layer on the lower electrode, and forming an upper electrode which covers the organic layer and is in contact with the lower portion of the partition.

